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Application No.: 10/823,244

Docket No.: JCLA12737-R

In The Claims:

1. (currently amended) A junction diode, comprising:

a first conductive type substrate;

a second conductive type embedded region, formed within the first conductive type

substrate;

a second conductive type well, formed within the second conductive type embedded

region, wherein the second conductive type well has a dopant concentration smaller than the

second conductive type embedded region, and the second conductive type embedded region

surrounds the second conductive type well, wherein the dopant concentration of the second

conductive-type embedded region under the second-conductive-type well is the same to-the

depart concentration of the second conductive type embedded region beside the second

conductive type well;

a one first conductive type doped region, formed in the second conductive type well; and

at least two second conductive type doped regions, formed in the second conductive type

embedded region beside the first conductive type doped region.

2. (original) The junction diode of claim 1, wherein the first conductive type substrate

comprises a P-type substrate.

3. (original) The junction diode of claim 1, wherein the second conductive type embedded

region comprises an N-type embedded region.

4. (original) The junction diode of claim 1, wherein the second conductive type well

comprises an N-type well.

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5. (original) The junction diode of claim 1, wherein the second conductive type well

comprises an epitaxial layer.

6. (original) The junction diode of claim 5, wherein the epitaxial layer comprises an N-

type epitaxial layer.

7. (original) The junction diode of claim 1, wherein the first conductive type doped region

comprises a P-doped region.

8. (original) The junction diode of claim 1, wherein the second conductive type doped

region comprises an N-doped region.

9. (original) The junction diode of claim 1, wherein junction diode further comprises a

plurality of isolation structures set between the first conductive type doped region and the second

conductive type doped region.

10. (previously presented) A junction diode, comprising:

a first conductive type substrate;

a second conductive type deep well, formed within the first conductive type substrate;

a first conductive type well, formed within the second conductive type deep well;

a first conductive type shallow well, formed within the first conductive type well, wherein

the first conductive type shallow well has a dopant concentration smaller than the first

conductive type well;

a plurality of first conductive type doped regions, formed in the first conductive type well;

and

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a plurality of second conductive type doped regions formed in the second conductive type deep well and one second conductive type doped region formed in the first conductive type shallow well, wherein the second conductive type doped region formed in the first conductive type shallow well is isolated from the second conductive type deep well by the first conductive type well and the first conductive type shallow well.

- 11. (original) The junction diode of claim 10, wherein the first conductive type substrate comprises a P-type substrate.
- 12. (original) The junction diode of claim 10, wherein the second conductive type deep well comprises an N-type deep well.
- 13. (original) The junction diode of claim 10, wherein the first conductive type well comprises a P-type well.
- 14. (original) The junction diode of claim 10, wherein the first conductive type shallow well comprises a P-type shallow well.
- 15. (original) The junction diode of claim 10, wherein the first conductive type doped region comprises a P-doped region.
- 16. (original) The junction diode of claim 10, wherein the second conductive type doped region comprises an N-doped region.
- 17. (original) The junction diode of claim 10, wherein the junction diode further comprises a plurality of isolation structures with each isolation structure set between every pair of first conductive type doped region and second conductive type doped region.